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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Hidemitsu Aoki, et al.

Examiner: S. T. Chaudhry

Serial No.: 10/075,566 ✓

Art Unit: 1746

Filed: February 13, 2002 ✓

Docket: 12688A

For: METHOD FOR CLEANING  
SEMICONDUCTOR WAFER AFTER  
CHEMICAL MECHANICAL POLISHING  
COPPER WIRING

Dated: September 8, 2003

Commissioner for Patents  
Alexandria, VA 22313-1450

RESPONSE

Sir:

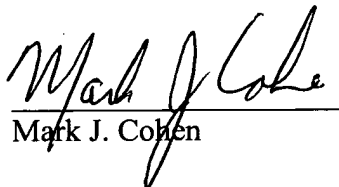
In response to the Office Action dated August 8, 2003, applicants provisionally elect, without traverse, ammonia as the first washer and polycarboxylic acids and ammonium salts of said polycarboxylic acid as the second washer.

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CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner of Patents and Trademarks, Alexandria, VA 22313-1450.

Dated: September 8, 2003

  
Mark J. Cohen

1746

<b>AMENDMENT TRANSMITTAL LETTER (Large Entity)</b>		Docket No.
Applicant(s): Hidemitsu Aoki, et al.		12688A

Serial No. 10/075,566	Filing Date February 13, 2002	Examiner S.T. Chaudhry	Group Art Unit 1746
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Invention:  
**METHOD FOR CLEANING SEMICONDUCTOR WAFER AFTER CHEMICAL MECHANICAL POLISHING COPPER WIRING**

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TO THE COMMISSIONER FOR PATENTS:

Transmitted herewith is an amendment in the above-identified application.  
The fee has been calculated and is transmitted as shown below.

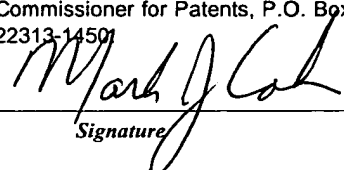
CLAIMS AS AMENDED					
	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST # PREV. PAID FOR	NUMBER EXTRA CLAIMS PRESENT	RATE	ADDITIONAL FEE
TOTAL CLAIMS	42 -	42 =	0 x	\$18.00	\$0.00
INDEP. CLAIMS	4 -	4 =	0 x	\$84.00	\$0.00
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					\$0.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT					\$0.00

- ☒ No additional fee is required for amendment.
- ☐ Please charge Deposit Account No. \_\_\_\_\_ in the amount of \_\_\_\_\_
- ☐ A check in the amount of \_\_\_\_\_ to cover the filing fee is enclosed.
- ☒ The Director is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account No. **19-1013/SSMP**
  - ☒ Any additional filing fees required under 37 C.F.R. 1.16.
  - ☒ Any patent application processing fees under 37 CFR 1.17.

  
Signature

Dated: September 8, 2003

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Mark J. C hen
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